Docket No.: 007734 FPS/MMCS/APC/DV (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Young J. PAIK Confirmation No.: 6290

Application No.: 10/665,165 Art Unit: 1763

Filed: September 18, 2003 Examiner: S. MacArthur

Title: FEEDBACK CONTROL OF A CHEMICAL MECHANICAL

POLISHING PROCESS FOR MULTI-LAYERD FILMS

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated September 7, 2007, please amend the aboveidentified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.